

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2815

PATENT APPLICATION
Docket No.: 8750-042
Client Ref. No.: SPX200211-0046US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Dae-Woong KANG, et al.

Serial No.: 10/758,802 Examiner: Matthew E. Warren

Filed: January 15, 2004 Group Art Unit: 2815

Confirmation No.: 6500

For: METHODS OF FABRICATING A SEMICONDUCTOR DEVICE
HAVING MULTI-GATE INSULATION LAYERS AND
SEMICONDUCTOR DEVICES FABRICATED THEREBY

Date: March 22, 2007

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Commissioner for Patents
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AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the Final Office Action, Paper No. 20070121, dated January 25, 2007,
please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 6 of this paper.